



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Art Unit : 1762
Examiner : Michael B. Cleveland
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Title : A METHOD AND APPARATUS
: FOR PRODUCING A
: PLASMA DISPLAY



22469

PATENT TRADEMARK OFFICE

Docket No.: 1084-98

Confirmation No.: 7453

Dated: August 19, 2002

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GRANTED

Box AF
Commissioner for Patents
Washington, DC 20231

AMENDMENT

RECEIVED

AUG 29 2002

TC 1700

Sir:

In response to the Official Action dated May 17, 2002, using marked-up versions of the Specification and Claims and also clean copies of such, Applicants amend as follows:

In the Specification (Marked-Up Version)

Please replace the paragraph spanning pages 38 and 39 with the following:

The number of outlet holes can be 1 to 6000, but a desirable range is 20 to [200] 2000. If the number of outlet holes is too small, it takes too much time for coating. If the number is 150 or more desirably, a phosphor layer suitable for a highly precise plasma display can be formed in a short time. If the number of holes exceeds 2000, it is difficult to secure the accuracy of the outlet holes, and to provide a highly precise plasma display. If the number of outlet holes is kept in a range of $16n \pm 5$ (n is a natural number), a phosphor layer suitable for a plasma display capable of being driven on a general purpose circuit can be easily formed.